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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Masaki Tamaru et al.

Filing Date:

Herewith

Title:

SEMICONDUCTOR DEVICE AND METHOD

OF MANUFACTURING THE SAME

Docket No.:

32811

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

sir:

In accordance with Rule 56, applicants are aware of the publications listed in the enclosed copy of Patent Office Form 1449. A copy of each of the publications is enclosed herewith.

Respectfully submitted,

Bv:

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